



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori, et al. Art Unit : 2822
Serial No. : 10/713,275 Examiner : Kiesha L. Rose
Filed : November 17, 2003
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check covering payment of the \$180 late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 6/22/05



John F. Hayden

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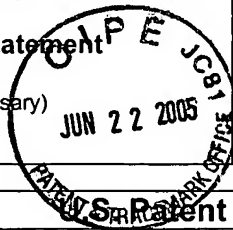
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No. 10/713,275
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Isamu Kobori, et al.	
		Filing Date November 17, 2003	Group Art Unit 2822



U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,183,780	02/02/1993	Noguchi et al.			02/20/1991
	AB	5,341,012	08/23/1994	Misawa et al.			07/31/1992
	AC	5,396,084	03/07/1995	Matsumoto			06/02/1993
	AD	5,420,055	05/30/1995	Vu et al.			11/16/1993
	AE	5,466,617	11/14/1995	Shannon			06/15/1994
	AF	5,506,165	04/09/1996	Sato			03/15/1995
	AG	5,637,187	06/10/1997	Takasu et al.			06/05/1995
	AH	5,815,223	09/29/1998	Watanabe et al.			09/30/1997
	AI	5,932,484	08/03/1999	Iwanaga et al.			10/15/1997
	AJ	6,136,625	10/24/2000	Nakazawa			07/07/1998
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
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Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	